

said member to a voltage signal.

14. (amended) A micromechanical device comprising:
 - at least one deflectable member, each deflectable member supported by a torsion hinge and spaced apart from a substrate;
 - at least two bias electrodes supported by said substrate, one on each side of an axis of said torsion hinge; and
 - a means associated with each said at least one deflectable member for selectively connecting said deflectable member to a voltage potential.
18. (amended) The micromechanical device of Claim 14, said means for selectively electrically connecting comprising:
 - a pass transistor; and
 - a capacitor, a first terminal of said capacitor connected to a gate terminal of said pass transistor and a second terminal of said capacitor connected to a ground potential.
19. (amended) A method of operating a micromechanical device, the method comprising:
 - grounding a deflectable member;
 - applying a reset signal to bias electrodes to reposition said selectively grounded deflectable member;
 - electrically floating said deflectable member such that said reset signal does not reposition said electrically floating deflectable member.
30. (amended) The method of Claim 24, further comprising:
 - applying an initialization signal to said bias electrodes to force said deflectable members of said first and second groups to a known state.
31. (amended) The method of Claim 30, said applying an initialization signal to said bias electrodes to force said deflectable members of said first and second groups to a known state comprising:
 - applying a voltage signal to one of said bias electrodes and a ground signal to another one of said bias electrodes.